



Image

Docket Number: 044020-0284163

PATENT APPLICATION

Client Reference: 01F181

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

SATOSHI INABA

Group Art Unit: 2826

Application No.: 10/042,264

Examiner: THOMAS L. DICKEY

Filed: January 11, 2002

Confirmation No.: 6258

For: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Mail Stop Patent Application
P. O. Box 1450
Alexandria, VA 22313-1450

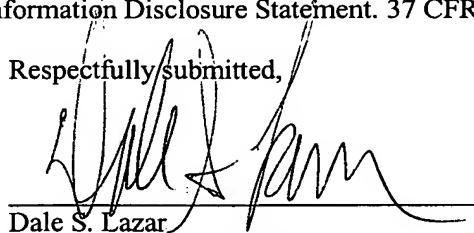
Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR 1.97(e)(1).

Respectfully submitted,


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